

10/182,593

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	"20040218341"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 21:40
S1	278899	((fixed stationary) adj2 (plate\$1 substrate\$1 wafer\$1 stage\$1 board\$1 base))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:00
S2	161078	((moving moveable movable) adj2 (plate\$1 substrate\$1 wafer\$1 stage\$1 board\$1 base))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:01
S3	75321	(((microelectromechanical micro-electro-mechanical micro-electromechanical (micro adj1 electro adj1 mechanical)) adj2 (system device unit apparatus)) MEMS)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:02
S5	797536	(control\$4 adj2 circuit\$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:03
S6	57117	(time with modulat\$3 with signal\$1)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:04
S7	1	S1 same S2 same S3 same S5 same S6	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:05
S8	1	S1 same S2 same S5 same S6	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:04
S9	24019	S1 same S2	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:10
S10	2593	S5 same S6	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:05
S11	3	S9 and S10	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:05

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S12	1	S3 and S11	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:05
S13	626	S1 same S2 same voltage\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 20:11
S14	4	S6 and S13 and S3	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2007/12/18 21:40